

ABSTRACT OF THE DISCLOSURE

Micro lens arrays (105) having high focusing efficiencies are provided. The high focusing efficiencies are achieved by accurately producing the
5 individual microlenses making up the array at high fill factors. Arrays of positive microlenses are produced by forming a master having a concave surface-relief pattern (101) in a positive photoresist (21) using direct laser writing. Through this approach, the problems associated with the convolution of a finite laser beam with a desired profile for a microlens are
10 overcome. The microlens arrays of the invention have focusing efficiencies of at least 75%.

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